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## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
MJ	4,849,797	07/18/1989	UKAI et al.	—	—	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	
MJ	Hatalis et al., "High Performance Thin Film Transistors in Low-Temperature Crystallized LPCVD Amorphous Silicon Films", August 1987, pp. 361-364, IEEE Electron Device Letters, Vol. EDL-8, No. 8

Examiner	Date Considered
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\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.